

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Form PTO-1449 (Modified)
(Use several sheets if necessary)

COMPLETE IF KNOWN

Application Number 307090,869
Confirmation Number 5296
Filing Date March 4, 2002
First Named Inventor Scott E. Moore
Group Art Unit 1741
Examiner Name
Attorney Docket No. 108298544US

Sheet 1 of 4

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U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No.	U.S. Patent or Application		Name of Patentee or Inventor of Cited Document	Date of Publication or Filing Date of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		NUMBER	Kind Code (if known)			
DN	AA	U.S. Application No. 09/651,779 (Atty. Docket No. 10829.8515US)		Moore	Filed 08/30/2000	
DN	AB	U.S. Application No. 09/651,808 (Atty. Docket No. 4373US)		Chopra et al.	Filed 08/30/2000	
DN	AC	U.S. Application No. 09/653,392 (Atty. Docket No. MTI-31044)		Chopra et al.	Filed 08/31/2000	
DN	AD	U.S. Application No. 09/887,767 (Atty. Docket No. 10829.8515US2)		Lee et al.	Filed 06/21/2001	
DN	AE	U.S. Application No. 09/888,002 (Atty. Docket No. 10829.8515US3)		Lee et al.	Filed 06/21/2001	
DN	AF	U.S. Application No. 09/888,084 (Atty. Docket No. 10829.8515US1)		Lee et al.	Filed 06/21/2001	
DN	AG	U.S. Application No. 10/230,463 (Atty. Docket No. 10829.8672US)		Lee et al.	Filed 08/29/2002	
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		NUMBER	Kind Code (if known)			
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Application Number 20/090,869
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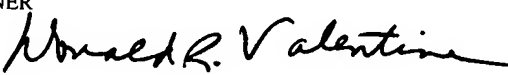
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		Group Art Unit	1741
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		Office	NUMBER	Kind Code (if known)				
DM	CJ	WO	00/59008		Talieh	10/05/2000		
DM	CK	WO	00/59682		Talieh	10/12/2000		

OTHER PRIOR ART-NON PATENT LITERATURE DOCUMENTS			
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DM	CL	FRANKENTHAL, R.P. and EATON, D.H., "Electroetching of Platinum in the Titanium-Platinum-Gold Metallization on Silicon Integrated Circuits," <i>Journal of The Electrochemical Society</i> , Vol. 123, No. 5, pp. 703-706, May 1976.	
DM	CM	BERNHARDT, A.F., CONTOLINI, R.J., MAYER, S.T., "Electrochemical Planarization for Multi-Level Metallization of Microcircuitry," <i>CircuiTree Journal</i> , Vol. 8, No. 10, pp. 38, 40, 42, 44, 46, and 48, Oct. 1995.	
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DM	CQ	KONDO, S. et al., "Abrasive-Free Polishing for Copper Damascene Interconnection," <i>Journal of the Electrochemical Society</i> , 147(10), pp. 3907-3913 (2000). (no month)	
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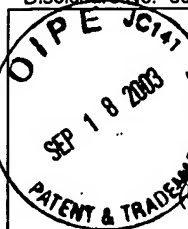
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Attorney Docket No. 108298544US

Disclosure No. 00-1194

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				Application Number	10/090,869
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				Group Art Unit	1742
Examiner Name	Donald R. Valentine				
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REV		PCT Written Opinion dated June 10, 2003 for PCT/US02/19495 filed June 20, 2002 (7 pages).	

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